	Application No.	Applicant(s)	-
Notice of Allowability	10/006,297 NISHIYAMA, NOBU		JIPO
	Examiner	Art Unit	1IKO
	Dhillin Nauvon	2828	السهم
	Phillip Nguyen	2020	•
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT THE OFFICE OF THE NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT THE OFFICE OF THE NOTICE O	(OR REMAINS) CLOSED in this ap or other appropriate communicatio GHTS. This application is subject	pplication. If not include on will be mailed in due of	d course. <b>THIS</b>
1. This communication is responsive to <u>10/13/04</u> .			
2. The allowed claim(s) is/are <u>1-8</u> .			
3. $\square$ The drawings filed on <u>06 December 2001</u> are accepted by the second sec	the Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority unday</li> <li>a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> <li>2.  Certified copies of the priority documents have</li> <li>3.  Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received. been received in Application No		ion from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONMITHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requ	uirements
5. A SUBSTITUTE OATH OR DECLARATION must be submininformal PATENT APPLICATION (PTO-152) which give			OTICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") must	t be submitted.		
(a) 🔲 including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached			
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the			back) of
7. DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F			ote the
Attachment(s)			
<ol> <li>Notice of References Cited (PTO-892)</li> <li>Dotice of Draftperson's Patent Drawing Review (PTO-948)</li> </ol>	5. Notice of Informal	, ,	<i>i</i> -152)
	6. ☐ Interview Summary Paper No./Mail Da	ate	
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date</li> </ol>	8), 7. Examiner's Amend	Iment/Comment	-
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Statem 9. ☐ Other	ent of Reasons for Allov	wance

Application/Control Number: 10/006,297

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## **DETAILED ACTION**

## Allowable Subject Matter

1. The following is an examiner's statement of reasons for allowance: Claims 1-8 are allowed because the prior art fails to teach or fairly suggest a semiconductor laser device as recited in claims 1 and 8.

Amano and Fujimaki fail to teach third lead portion having a first side portion amd a second side portion, the first side portion disposed to one side of the second lead portion and the second side pordon disposed to another side of the second lead portion.

Ogino et al. ('794) discloses in Figures 1 and 4 a laser device having first, second, and third lead portions, 3a, 4a, and 4b, respectively. However, Oginio does not teach the third lead portion having two portions on two sides of the second lead portion.

2. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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## Citation of Pertinent References

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

The patent to Ogino et al. discloses Semiconductor Laser Devie, U.S. Patent No. 5825794

The patent to Fujimaki et al. discloses Semiconductor Laser with Encapsulated Lead Members, U.S. Patent No. 530946

The patent to Amano et al. discloses Laser Diode Device having a Protective Layer on Its Light-Emitting End Face, U.S. Patent No. 5355385

## Communication Information

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Phillip Nguyen whose telephone number is 571-272-1947. The examiner can normally be reached on 9:00 AM - 6:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, MINSUN HARVEY, can be reached on 571-272-1835. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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